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**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Jung-Wook Kim, et al. Examiner: Michail Kornakov  
Serial No: 10/606,512 Group Art Unit: 1746  
Filed: June 26, 2003 Docket: 8054-23 (AW8037US/JJ)  
For: **METHOD FOR CLEANING A PROCESSING CHAMBER AND METHOD  
FOR MANUFACTURING A SEMICONDUCTOR DEVICE**

Mail Stop: Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO NOTICE OF NON-COMPLAINT AMENDMENT**

Sir:

In response to the Notice of Non-Compliance mailed on June 15, 2006, Applicants hereby submit a corrected claim listing that includes a proper status identifier for each claim of the above-referenced patent application.

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**CERTIFICATE OF MAILING 37 C.F.R. §1.8(a)**

I hereby certify that this correspondence (and any document referred to as being attached or enclosed) is being deposited with the United States Postal Service as first class mail, postage paid in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450, on **July 17, 2006**.

Dated:

7/17/06

  
Scott L. Appelbaum